

L Number	Hits	Search Text	DB	Time stamp
10	21610	(g01n021/88).ipc.	EPO; JPO; DERWENT; IBM_TDB	2004/03/15 11:49
11	651	((g01n021/88).ipc.) and ((semiconduct\$ wafer) near (inspect\$ defect\$))	EPO; JPO; DERWENT; IBM_TDB	2004/03/15 11:50
12	121	((g01n021/88).ipc.) and ((semiconduct\$ wafer) near (inspect\$ defect\$))) and (laser fourier)	EPO; JPO; DERWENT; IBM_TDB	2004/03/15 11:51